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Docket No. 103-1009

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Seung Jun LEE et al.

Application 11/050,752

Group Art Unit: 2125

Filed: February 7, 2005

Examiner Zoila E. Cabrera

Customer No.: 38209

Confirmation No. 7187

For: SYSTEM TO AND METHOD OF MONITORING CONDITION OF PROCESS TOOL

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

*OK to Enter
CB 12/24/06*

Sir:

In response to the Office Action mailed July 26, 2006, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.